2814 ISW

DOCKET: CU-2757

PATENT PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Woo Seock CHEONG

Serial No.: 10/034,228

Filed: December 28, 2001

For: METHOD OF MANUFACTURING A

SEMICONDUCTOR DEVICE

GRP ART UNIT: 2814

Ex.: Pham, Long

Certification under 37 C.F.R. §1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, on June 15, 2004.

Vangelis Economou - Reg. No. 32,341

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated March 29, 2004, please amend the above-identified application as follows:

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in this application: